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In re Reissue Application of :
Meisburger et al.
Reissue Application No. 09/502,534 :
Filed: February 10, 2000 :
Original Patent No. 5,717,204 :
Issue Date: February 10, 1998 :
For: INSPECTING OPTICAL MASKS WITH :
ELECTRON BEAM MICROSCOPY :

OFFICE OF PETITIONS
A/C PATENTS

DECISION ACCORDING
STATUS

This is a decision on the petition under 37 CFR 1.47(a) filed October 2, 2000.

The petition is granted.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This reissue application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(a), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the Declaration. Notice of the filing of this reissue application will also be published in the Official Gazette.

To expedite the examination in progress, this reissue file is being forwarded to Technology Center AU 2878. It is noted that the declarations filed with the petition lack compliance with 35 USC 115 and 37 CFR 1.63(a)(3) as they lack the citizenship of every named inventor, e.g., Mr. Meisburger and Mr. Emge. AS THIS IS A REQUIREMENT OF STATUTE NOT SUBJECT TO WAIVER, CORRECTED SUPPLEMENTAL REISSUE DECLARATIONS SHOULD BE FILED PROMPTLY OR WHEN REQUIRED BY THE EXAMINER.

Telephone inquiries related to this decision should be directed to the undersigned at (703) 305-1820.

Brian Hearn
Brian Hearn
Petitions Examiner
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy

Enclosure: Corrected Filing Receipt